



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG790695793
Report verification at igi.org

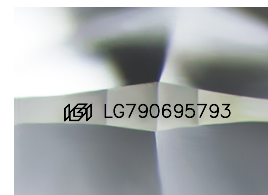
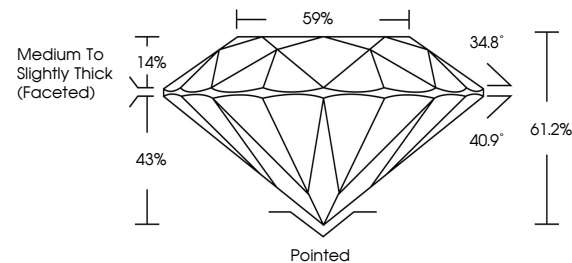
April 20, 2026	
IGI Report Number	LG790695793
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	6.43 - 6.46 X 3.94 MM
GRADING RESULTS	
Carat Weight	1.02 CARAT
Color Grade	D
Clarity Grade	VVS 2
Cut Grade	IDEAL

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG790695793

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

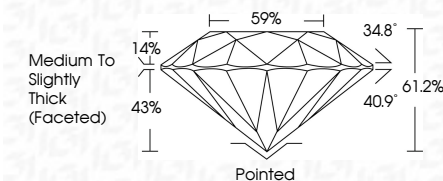
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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April 20, 2026
ICI Report No LG790695793
ROUND BRILLIANT

6.43 - 6.46 X 3.94 MM	Carat Weight	1.02 CARAT
	Color Grade	D
	Clarity Grade	VVS 2
	Cut Grade	IDEAL
	Depth	61.2%
	Table	59%
	Girdle	Medium to Slightly Thick (Faceted)
	Culet	Pointed
	Polish	EXCELLENT
	Symmetry	EXCELLENT
	Fluorescence	NONE
	Comments	See 1370049293

Comments:
This Laboratory Grown Diamond was
created by Chemical Vapor Deposition
(CVD) growth process.